Form PTO-1449 (Rev. 2-88)

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTY, DOCKET NO. 7162-65

Sheet 1 of 2
APPLICATION NO. 10/635,629

APPLICANT

BROWN, et al. FILING DATE 8/6/2003

GROUP

BY APPLICANT

INFORMATION DISCLOSURE STATEMENT

$\overline{a}$	(Use several sheets if necessary)				8/6/2003			
<b>3</b>			U.S	S. PATENT DOCUMENTS				
KAMINER' S INITIAL	Cite No.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DA	
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10/635,629

INFORMATION DISCLOSURE STATEMENT

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BROWN, et al.

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Sheet 1

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known						
Application Number	10/635629					
Filing Date	8/6/2003					
First Named Inventor	BROWN					
Art Unit	2817					
Examiner Name						
Attorney Docket Number	7162-0065					

			U. S. PATEN	DOCUMENTS	
Examiner Initials*	Cite No.1	Document Number  Number-Kind Code <sup>2 (f Innown)</sup>	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
55		<sup>US-</sup> 5162972	11/10/1992	GRIPSHOVER, et al.	
41		<sup>US-</sup> 6515235	02/04/2003	MOLLER	
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	Cite No.1	No.1 Foreign Patent Document	Cite Foreign Patent Document Publication Date MM-DD-YYYY	No.1 Date Applicant of Cited Document	Cite Foreign Patent Document Publication Name of Patentee or Applicant of Cited Document Where Relevant Passages  MM-DD-YYYY  Publication Name of Patentee or Applicant of Cited Document Where Relevant Passages Or Relevant Figures Appear

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Examiner Signature	1	tach	4.1		Date Considered	12/8/04	

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